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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10075602	FILING DATE 02/15/2002	CLASS 438	SUBCLASS 706	GAU 1765	EXAMINER Walter Eronini
<b>**APPLICANTS:</b> Hung Jeffrey; Lee Brian;					
<b>**CONTINUING DATA VERIFIED:</b> THIS APPLICATION IS A DIV OF 09/002,007 12/31/1997 V					
BEST AVAILABLE COPY					
<b>** FOREIGN APPLICATIONS VERIFIED:</b>					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiner's Initials				ATTORNEY DOCKET NO 015290-592	
TITLE: Etching process for organic anti-reflective coating					
U.S. DEPT. OF COMM. PAT. & TM-PTO-436 (Rev. 12-94)					

<b>NOTICE OF ALLOWANCE</b>		<b>Amount Due</b>		<b>Date Paid</b>	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR</b>		<b>FILED WITH</b>	
<b>DISCLAIMER</b>		<b>FILED WITH</b>		<b>FILED WITH</b>	

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